

The Engineering of Small Scale Thermal Systems: A National Science Foundation Perspective

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Research impact and the role of NSF

Small scale thermal systems—a contemporary driver for research in thermal transport

Examples of NSF supported research that impact thermal systems for electronics thermal management

Opportunities and Directions



The Nature of Engineering Research

All engineers work on the development of systems, in one way or another

- Fundamental engineering research is not system specific
- Applied engineering research is system specific
- Both are necessary for the development of useful systems
- Engineers do not need to apologize for working on real systems. That's what we are paid to do



The Impact of Research





NSF's Role in Engineering Research





NSF's Role in Engineering Research

Enable Fundamental research That is INNOVATIVE That has IMPACT

> Impact on Engineering Science

Impact on Technology and Society

Impact on People





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Technology Drivers for Research in Thermal Transport

Nuclear and conventional steam power generation has driven research in multi-phase flow and transport for 50 years

Terrestrial and aerospace propulsion has provided the technology driver for convective transport research for 60 years

Electronics thermal management is the single most important contemporary technology driver for thermal transport research



Small Scale Thermal Systems for Electronics Cooling



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NSF TTTP Program Scope

Phase change (liquid/vapor; solid/liquid)

High speed annular flow; microscale condensation and evaporation; multi-component solidification; nano-enhanced boiling phenomena

High heat flux applications, especially at small length scales Microchannel flows; microelectronics cooling

• Complex flow processes (in terms of driving forces, geometry, etc.)

Turbulent combustion with radiation; turbulence with real surface roughness; magnetic and electric fields; building flow environments

Manufacturing and materials processing

Laser materials interactions; optical fiber drawing; MEMS processing; crystal growth; thin film processing

Nanoscale transport phenomena

Energy conversion devices; semiconductor devices; multiscale conduction; interfacial phenomena; sub-nano second thermal transport; nanoscale thermal instrumentation; nanofluids; nano-materials processing

Properties

Thermal/electrical properties of nano-structures: Non-isotropic conductivity; thermal properties of thin films; shape memory alloys; high temperature gas radiative properties

Design, control and optimization

Inverse design; 2nd Law optimization; active control of convection



TTTP Research Themes Relative to CTS Priority Areas

CTS Priority Areas

TTTP Themes

Nanoscale Science/Engr

Safety and Security

Smart Mfg and Processing

Environmentally Friendly/Energy Focused Processes/Products Synthesis, Mfg, and Integration of Nano-Thermal Systems

High Heat Flux Micro-Engineering

Thermal Transport in Materials Processing and Mfg





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NSF Award 0506830 NIRT Integrated Study of Thermoelectric Transport and Energy Conversion in Bismuth-Based Nanowires

Gang Chen et al. (MIT)

Rejected Heat to Heat Exchanger



Device Dissipated Power

The use of thermoelectric energy conversion has been hampered by low efficiencies

The efficiency scales with the following figure of merit:

Joule Seebeck Coeff. Heating Electron Cooling

Reverse Heat Leakage Through Heat Conduction

7T = -

The use of nanocomposites shows great promise for greatly improving efficiencies



Transport in Nanocomposites

Si Nanoparticle Ge Host

• Challenges:

Random structure Variable particle diameter Large computational power Phonon transport Electron transport



2D Period Structure



Monte Carlo Simulation



The promise of nanocomposites

- Engineered nanomaterials hold great promise for energy conversion.
- Significant progress has been made in the ability to simulate thermal (phonon) and electrical (electron) transport
- Nanocomposites can improve thermoelectric figureof-merit by reducing phonon thermal conductivity while increasing electron power factor.
- The figure of merit has more than doubled in the past five years as a result of nanoengineering!

NSF Award CAREER 0239179 Thermal Transport and Thermoelectric Measurements of Nanotransistors, Nanowires, and Superlattices Li Shi (U Texas)









(a-b) A micro-device for characterization of structurethermal/thermoelectric property relationships of nanotubes and nanowires;

(c) The measurement results of the thermal conductance of a single-wall carbon nanotube (SWCNT) is very close to the calculated ballistic thermal conductance of a 1-nm-diameter SWCNT;

(d-e) Schematic showing two opposite phonon flows at different temperatures transported ballistically in a SWCNT.

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NSF NIRT Award Number: 0238888 Nanotube based structures for high resolution control of thermal transport Cecilia Richards et al., Washington State



Images of patterned vertically aligned carbon nanotube turf



NSF NIRT Award Number: CTS-0404370 Nanotube based structures for high resolution control of thermal transport Cecilia Richards et al., Washington State

- Carbon nanotubes are incorporated into microscale composites to create a new kind of mesoscale device, a thermal switch
- Arrays of thermal switches will then be produced in batch to create sheets with spatially and temporally controllable "digital" thermal conductivity
- Carbon nanotubes (CNT's) bridge scales from nanometers to micrometers, and MEMS techniques bridge scales from micrometers to millimeters
- Manufacturing across six orders of length scales from nano to meso is made possible by utilizing the mixed-scale architectures of high aspect ratio CNT's and two-dimensional lithographic-based low-aspect ratio MEMS fabrication techniques.



NSF NIRT Award Number: CTS-0404370 Thermal conductance of solid-solid interfaces David Cahill, Univ Illinois Urbana-Champagne

1000 DMM 0 TiN/MaO Thermal Conductance (MW m⁻² K⁻¹) Equivalent Film Thickness (nm) 100 10 Pb/diamond (1993) 10 100 H-diamond radiation limit Bi/diamond 1000 100 500 40 Temperature (K)

- The time-domain thermoreflectance (TDTR) technique for measuring the temperature of interfaces was greatly improved
- The technique was used to measure the heat conduction in thin films and across interfaces
- Data for these interfaces between materials with highly dissimilar spectra of lattice vibrations were used to test current theoretical and empirical understanding of interfacial heat transfer
- The established theories for the thermal conductance of interfaces become increasingly unreliable as the Debye temperature of the substrate increases



NSF Award Number: CTS-0245642 The Critical Heat Flux Condition in Micro-Channels Jensen, M and T. Borca-Tasciuc, RPI; Kandlikar, S. RIT



Test-chip designed to investigate two-phase flow and boiling phenomena in microchannels

- The primary project objective is to develop a better quantitative and qualitative understanding of and prediction capabilities for the CHF condition in single and multiple parallel micro-channels
- The CHF condition with water and R123 in single metal tubes and single microfabricated channels is being investigated at RPI
- The local boiling phenomenon in multiple parallel channels with R123 in large monolithic metal blocks is being investigated at RIT

NSF Award Number: CTS-0336757 Coupling the High Resolution of Laser Measurements and Finite-Element Simulations to Understand Transport Phenomena during Microdroplet Deposition Daniel Attinger *, Jon Longtin **

Columbia University*, State University of New York at Stony Brook**



The temperature under a single impinging droplet was measured using a new thermoreflectance technique

The agreement with the finite element simulations was excellent





- Coupled evaporation kinetics, viscous flow, surface tension, heat conduction, non-local influence of the wall
 - effect of atomic granularity?
 - proposed continuum models [e.g. Ajaev & Homsy, 2001]
- Studied with MD using simple fluids (for now)
- Findings
 - Kapitza resistance important at wall-liquid boundary
 - weakly wetting: good agreement with asymptotic model
 - strongly wetting: failure of Newtonian constitutive model
- Freund, Phys. Fluids (2005)







NSF GOALI: Nanofluids P. Phelan, ASU



Enhanced thermal conductivity is greater than what is predicted by conventional theory

k = nanofluid
thermal
conductivity

k_f = thermal conductivity of base fluid

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Convection Induced by Brownian Motion



- Effects of Brownian motion characterized through a "Brownian Reynolds Number."
- Brownian motion causes enhanced convection, as well as enhanced stirring

T = temperature ρ_n = nanoparticle density **d** = nanoparticle diameter ν_f = fluid viscosity

$$\operatorname{Re} = \frac{1}{\nu_f} \sqrt{\frac{3k_b T}{m}} = \frac{1}{\nu_f} \sqrt{\frac{18k_b T}{\pi \rho_n d}}$$



Spread of the Fluorescent Dye in Water and in Nanofluid



Deionized (Pure) Water

1% 20-nm Al₂O₃ Nanofluid



Nanofluid Characteristics in Pool Boiling Ranganathan Kumar University of Central Florida Supported by NSF NER Award No. 0404174

2 nm

Modification of Boiling Curve due to Nanoparticle additives



Figure 1. Modification of Boiling Curve due to Nanoparticle additives

High resolution TEM micrograph 3-8 nm nanoceria particles added to fluid



Metal Based Micro Heat Exchangers

W. Meng, S. Ekkad, LSU

Three Main Areas:

- Focus on fabricating microchannels in metals like Cu and Al.
- Reactive joining to enclose microchannels
- Thermal testing of micro heat exchanger performance



Microfabrication



Figure 1. Schematic of the conventional LiGA microfabrication process steps: 1) the primary pattern is generated in polymeric resists by deep X-ray/UV lithography, 2) resist development, 3) electrodeposition metal developed resist into recesses, 4) dissolution of remaining resist, yielding electrodeposited an metallic HARMS, 5-6) compression molding with electrodeposited the primary HARMS insert followed by demolding vields the replicated HARMS. Economic mass fabrication of microparts hinges on the molding replication step.

Microfabrication



Figure 2. Surface engineering of a Ni microscale mold insert with an array of Ni microposts ~400µm in height by conformal deposition of a Ti-C:H nanocomposite coating: (left) cross-section perpendicular to a Ni micropost; (left middle) cross-section parallel to a Ni micropost; (right middle) an array of molding replicated microholes in an Al plate with depths ~400µm; (right) the surface engineered mold insert consisting of an array of Ti-C:H coated Ni microposts after multiple molding replication runs at ~460°C.



Figure 3. Hybrid fabrication and application of microscale Ta mold inserts: (left) morphology of as-µEDMed Ta surface showing the existence of the ASL with nodules and cracks; (left middle) cross-sectional electron diffraction pattern showing that the structure of ASL is B1-TaC rather than A2-Ta; (right middle) overview of surface engineered Ta HARMS insert consisting of an array of rectangular micro-protrusions fabricated by µEDM followed by ECP and conformal Ti-C:H deposition; (right) an array of Cu microchannels replicated at ~500°C from the Ta insert by molding. The width and depth of the Cu microchannels are ~160µm and ~220µm, respectively.



Microfabrication



Figure 8. Need for microchannels with geometrically complex patterns: a schematic of converging microchannels from Ref. 72.



Figure 9. Feasibility of and challenges for pattern transfer with parallel µEDM: (left) an array of electrodeposited Ni rectangular protrusions with widths of ~185µm and ~276µm; (left middle) corresponding structures transferred onto a Ta insert blank by parallel µEDM, after the removal of the ASL by ECP. The depth of the transferred Ta HARMS is ~400µm; (right middle) electrodeposited Ni interdigitated structure. The widths of the long-ridges and short-fingers are respectively ~330µm and ~80µm. The height of the Ni HARMS is ~1200µm; (right) corresponding transferred structures on a W plate. The arrow indicates one example of excessive erosion on W due to interactions between primary Ni microfeatures in close proximity during µEDM.



Where are the frontiers?¹

TTTP Looking Forward

- Challenges remain in continuum level phenomena that will continue to nurture mature fields at a lower level
 - Multi-phase, multi-component, high turbulence, coupled reacting flows with heat transfer, but
- Micro and Nano-scale Engineering will continue to be the dominant driver of modern Thermal Science
 - High heat flux, small scales, convective and nanoscale interfacial phenomena driven by emerging integrated electronics, future nanoelectronics, and biointerfaces
 - Synthesis, characterization and modeling of nanomaterials and nanostructures and integration into nanosystems; motivates research in nano-manufacturing
- Rapid transition of ideas, measurements, and modeling to two emerging, transcendant areas:
 - Sustainable energy (Hydrogen, Nano-photovoltaics)
 - Cellular and Molecular engineering

¹"Frontiers in Transport Phenomena Research and Education: Energy Systems, Biological Systems, Security, Information Technology, and Nanotechnology" a NSF/ TTTP Funded Workshop, scheduled for March 2007